



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 17, 2025

IGI Report Number **LG757508431**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.58 - 8.63 X 5.42 MM**

GRADING RESULTS

Carat Weight **2.50 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

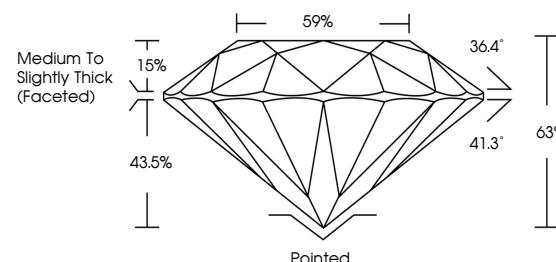
IGI **LG757508431**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

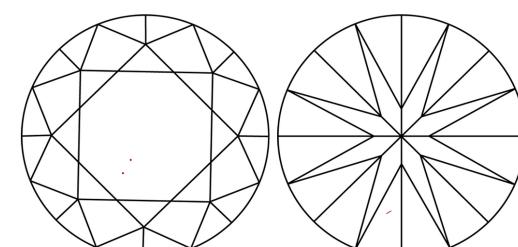
Type Ila

LG757508431
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

LABORATORY GROWN DIAMOND REPORT



December 17, 2025

IGI Report Number **LG757508431**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.58 - 8.63 X 5.42 MM**

GRADING RESULTS

Carat Weight **2.50 CARATS**

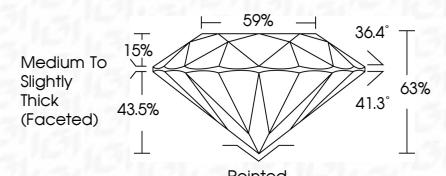
Color Grade **F**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**



Sample Image Used



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG757508431**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

www.igi.org

© IGI 2020, International Gemological Institute



FD - 10 20



December 17, 2025	IGI Report No. LG757508431
ROUND BRILLIANT	ROUND BRILLIANT
8.58 - 8.63 X 5.42 MM	8.58 - 8.63 X 5.42 MM
2.50 CARATS	2.50 CARATS
F	F
VS 1	VS 1
EXCELLENT	EXCELLENT
63%	63%
69%	69%
Medium To Slightly Thick (Faceted)	Medium To Slightly Thick (Faceted)
43.5%	43.5%
15%	15%
Pointed	Pointed
Cut Grade	Cut Grade
Depth	Depth
Table	Table
Girdle	Girdle
Polish	Polish
Symmetry	Symmetry
Fluorescence	Fluorescence
Inscription(s)	Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila